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JPW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JAMES BROC STIRTON
KEVIN R. LENSING
HORMUZDIAR E. NARIMAN
STEVEN P. REEVES

Examiner: Roy M. Punnoose

Group Art Unit: 2877

Att'y Docket: 2000.092400/TT5002

Customer No.: 23720

Serial No.: 10/084,987

Filed: February 28, 2002

For: METHOD OF USING HIGH YIELD
SPECTRA SCATTEROMETRY
MEASUREMENTS TO CONTROL
SEMICONDUCTOR MANUFACTURING
PROCESSES, AND SYSTEMS FOR
ACCOMPLISHING SAME

RESPONSE TO OFFICE ACTION DATED APRIL 16, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

May 17, 2004

Date

Mary Paul
Signature

This paper is submitted in response to the Office Action dated April 16, 2004, for which the three-month date for response is July 16, 2004.

No fees are believed to be due in connection with the present paper. However, should any fees be required under 37 C.F.R. §§ 1.16 to 1.21, the Director is authorized to deduct such fees from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT5002. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.092400.